



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/696,432 Confirmation No. 6825
Applicant : Ying-Lang Wang
Filed : October 29, 2003
TC/A.U. : 2813

Title : CMP Process Leaving No Residual Oxide Layer or Slurry
Particles

Docket No. : N1085-90131 (TS01-167CB)
Customer No. : 08933

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING,
37 C.F.R. §1.8(a)**

I certify that this correspondence and the
enclosures mentioned therein are being deposited
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22313-1450.

Richard A. Paikoff
Richard A. Paikoff, Reg. No. 34,892

7/12/06
Date

AMENDMENT AND RESPONSE

Sir:

In response to the Office Action of December 29, 2005, please amend the above-
identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks begin on page 4 of this paper.